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**FACSIMILE TRANSMISSION COVER SHEET**

Date: March 14, 2005  
To: United States Patent and Trademark Office  
Examiner: Pham, Long; Art Unit: 2814  
Fax: (703) 872-9306  
Re: **Application Serial No.: 10/761,009**  
Filing Date: 1/20/2004; First-Named Inventor: Jeon  
Attorney Docket No.: 0180154  
From: Farjami & Farjami LLP

Number of pages including the cover sheet: 7

Message:

Enclosed please find the Amendment and Response to Office Action dated March 8, 2005.  
Thank you.

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Attorney Docket No.: 0180154

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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<p>In re Application of: <b>Jeon, et al.</b></p> <p>Serial No.: 10/761,009</p> <p>Filed: 01/20/2004</p> <p>For: <b>Method for Forming a Thin, High Quality Buffer Layer in a Field Effect Transistor and Related Structure</b></p>
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Art Unit: 2814

Examiner: Pham, Long

AMENDMENT AND RESPONSE TO OFFICE ACTION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir/Madam:

This is in response to the Office Action dated March 8, 2005 in the above-referenced patent application. Please enter the following amendments.